



Patent
Case No.: 57181US002

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

First Named Inventor: BAUDE, PAUL F.

Application No.: 10/076003

Group Art Unit: ~~2812~~ 2814

Filed: February 14, 2002

Examiner: Unknown Trinh

Title: APERTURE MASKS FOR CIRCUIT FABRICATION

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
Washington, DC 20231

<u>CERTIFICATE OF MAILING</u>	
I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, DC 20231 on:	
DEC 12 2002	
Date	Signed by: Lydia M. Cahill

Dear Sir:

Pursuant to 37 CFR §§ 1.56, 1.97, and 1.98, enclosed is a completed Form PTO-1449, citing references submitted for consideration by the Examiner. A copy of each cited reference is also enclosed. It is respectfully requested that the Examiner initial and return the enclosed Form PTO-1449 to indicate that each reference has been considered.

If a first Office Action on the merits has been mailed prior to the mailing date of this document, please charge the fee for consideration of an Information Disclosure Statement set forth in 37 CFR § 1.17(p), and if necessary, please charge any additional fees, or credit any overpayment to Deposit Account No. 13-3723.

Respectfully submitted,

December 11, 2002
Date

By:

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